



IPW

PATENT
Customer No. 22,852
Attorney Docket No. 04329.3109

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
)
Jota FUKUHARA, et al.) Group Art Unit: 2813
)
Application No.: 10/635,676) Examiner: Blum, David S.
)
Filed: August 7, 2003)
)
For: SEMICONDUCTOR DEVICE AND)
MANUFACTURING METHOD)
THEREFOR)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

RESPONSE TO RESTRICTION REQUIREMENT

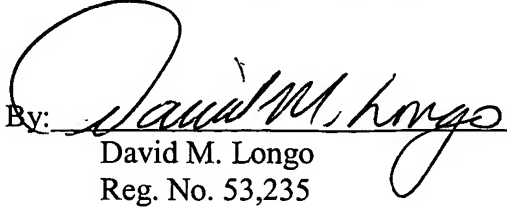
In the Restriction Requirement mailed February 2, 2005, with a period for response extending to March 2, 2005, the Examiner required restriction under 35 U.S.C. § 121 between Group I (claims 1-12) and Group II (claims 13-26). Applicants elect to prosecute Group I, claims 1-12, characterized by the Examiner as drawn to a method of making a semiconductor, without traverse.

Please grant any extensions of time required to enter this response and charge any additional required fees to our deposit account 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,
GARRETT & DUNNER, L.L.P.

Dated: February 28, 2005

By: 
David M. Longo
Reg. No. 53,235

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